

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/762,453	CHANG, AN-SHENG	
Examiner	Art Unit	
David E. Martinez	2181	

	SEARCHED				
Class	Subclass	Date	Examiner		
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INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	

SEARCH NOT (INCLUDING SEARCH)
	DATE	EXMR
East see attached	6/8/2006	DM
710/15,17,36,58,59.ccls. 714/1,2,14,47,48.ccls. with keywords and text search	6/8/2006	DM
eDan Inventor Search	6/8/2006	DM
Databases: US Patents, US PGPUBS, USOCR, EPO, JPO, Derwent, IBM_TDB.	6/8/2006	DM